

Docket No.: 49959-051

1765
#3
PATENT

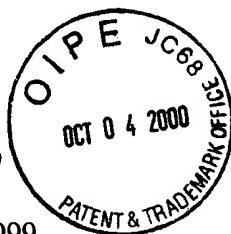
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shijian Li, et al.

Serial No.: 09/469,709

Filed: December 21, 1999



Group Art Unit: 1765

Examiner: unassigned

For: HIGH THROUGH-PUT CU CMP WITH SIGNIFICANTLY REDUCED EROSION AND DISHING

TRANSMITTAL OF FORMAL DRAWINGS

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

At the time the above application was filed, informal drawings were presented with the application.

The formal drawings are submitted herewith.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Eric J. Kraus

Eric J. Kraus

Registration No. 36,190

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 EJK:brd
Date: October 4, 2000
Facsimile: (202) 756-8087

RECEIVED
OCT - 6 2000
TECHNOLOGY CENTER 1700